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 Inventor: MOORE, JOHN Classification: 438/770.000
 Status: 71 - RESPONSE TO NON-FINAL OFFICE ACTION ENTERED AND FORWARDED TO EXAMINER
 Title: METHODS OF FORMING OXIDE REGIONS OVER SEMICONDUCTOR SUBSTRATES

Outgoing tab report (20 items sorted by NONE in NO order)

Img	Status	Doc Code	Document Type	Mail Date	Pages	Annotations
	7	CTFR	Final Rejection	12/04/2003	10	
	7	892	List of references cited by Examiner	12/04/2003	1	
	7	CTNF	Non-Final Rejection	05/12/2003	10	
	7	892	List of references cited by Examiner	05/12/2003	1	
	7	1449	List of References cited by Applicant	05/12/2003	1	
	7	1449	List of References cited by Applicant	04/04/2003	1	
	7	1449	List of References cited by Applicant	04/04/2003	8	
	7	1449	List of References cited by Applicant	02/24/2003	1	
	7	NOA	Notice of Allowance	01/23/2003	7	



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	7	NOA	Notice of Allowance	11/05/2002	7	
	7	1449	List of References cited by Applicant	10/07/2002	1	
	7	1449	List of References cited by Applicant	08/06/2002	1	
	7	CTFR	Final Rejection	05/08/2002	14	
	7	892	List of references cited by Examiner	05/08/2002	1	
	7	1449	List of References cited by Applicant	05/08/2002	2	
	7	1449	List of References cited by Applicant	03/18/2002	1	
	7	CTNF	Non-Final Rejection	12/06/2001	15	
	7	892	List of references cited by Examiner	12/06/2001	1	

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	7	1449	List of References cited by Applicant	12/06/2001	3	
	7	CTRS	Requirement for Restriction/Election	08/14/2001	4	